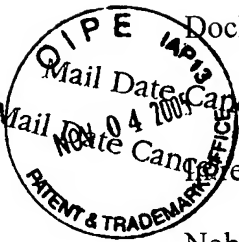


JPW



Docket No.: 057810-0084

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Nobuhiko HAYASHI, et al.

Application No.: 10/796,154

Filed: March 10, 2004

: Customer Number: 20277

: Confirmation Number: 2539

: Group Art Unit: 2811

: Examiner: A. Le

For: NITRIDE-BASED SEMICONDUCTOR ELEMENT AND METHOD OF FORMING
NITRIDE-BASED SEMICONDUCTOR

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated October 20, 2005.